



Attorney Docket: 2285/51302  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: YUMIKO KAWANO ET AL.

Serial No. 10/052,306

Filed: January 18, 2002

Continuation of: International Application No.: PCT/JP00/04889

International Filing Date: July 21, 2000

Title: METHOD AND APPARATUS FOR MANUFACTURING  
SEMICONDUCTOR DEVICE

TRANSMITTAL LETTER

Box SN

Commissioner for Patents  
Washington, D.C. 20231

Sir:

The following are submitted herewith for filing in the above-identified application:

1. Executed Declaration and Power of Attorney
2. Application Data Sheet
3. English Translation
4. Authorization to Charge to Deposit Account No. 05-1323:

\$306 - 17 extra claims over 20

\$84 - 1 extra independent claim

\$130 - surcharge late filing of Declaration

\$130 late filing of translation

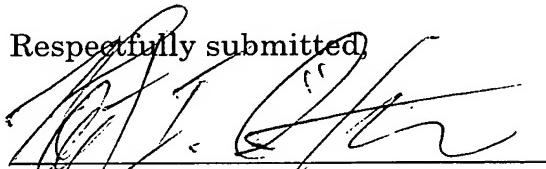
\$650 Total to be charged to Deposit Account

06/26/2002 SSEEHEI 00000017 051323 10052306  
01 FC:03 306.00  
02 FC:02 84.00  
03 FC:05 130.00  
04 FC:139 130.00

If there are any questions regarding this submission or the application in general, a telephone call to the undersigned would be appreciated since this should expedite the prosecution of the application for all concerned.

If necessary to effect a timely response, this paper should be considered as a petition for an Extension of Time sufficient to effect a timely response, and please charge any deficiency in fees or credit any overpayments to Deposit Account No. 05-1323 (Docket #2285/51302).

Respectfully submitted,



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June 21, 2002

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